

Electronic Patent Application Fee Transmittal

Application Number:	10690507			
Filing Date:	23-Oct-2003			
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing			
First Named Inventor/Applicant Name:	Ji Yong Park			
Filer:	Hung H. Bui/Karen Jones			
Attorney Docket Number:	1514.1032			

Filed as Large Entity

Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Extension - 2 months with \$0 paid	1252	1	450	450
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				1240